

Atomic layer deposition of alumina on g-Al₂O₃ nanofibres

Jõgiaas, Taivo; Arroval, Tõnis; **Kollo, Lauri**; **Hussainova, Irina** Physica status solidi (a) : applications and materials science 2014 / p. 403-408 : ill <https://doi.org/10.1002/pssa.201330083> [Journal metrics at Scopus](#) [Article at Scopus](#) [Journal metrics at WOS](#) [Article at WOS](#)

Oxygen barrier properties of Al₂O₃- and TiO₂-coated LDPE films

Lange, Sven; Arroval, Tõnis; Saar, Rando; Kink, Ilmar; Aarik, Jaan; **Krumme, Andres** Polymer-plastics technology and engineering 2015 / p. 301-304 : ill <http://dx.doi.org/10.1080/03602559.2014.977426>